## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In respplication of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL-MECHANICAL POLISHING APPARATUS AND METHOD TO MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 2399

Examiner SHANTESE L. McDONALD

Customer No. 23494

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## **CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450,, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

Jay M. Cantor, Reg. No. 19,906

## **AMENDMENT UNDER 37 C.F.R. 1.111**

In response to the Office action dated July 1, 2005, please amend the above-

identified application as follows: